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Application Number	10711649
Filing Date	2004-09-24
First Named Inventor	Kawamura
Art Unit	2813
Examiner Name	Monica D. Harrison
Attorney Docket Number	SSIT-114

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MDH	1	T. FUKUDA ET AL., "A Novel Method of Removing Impurities from Multilevel Interconnect Materials" (XP001232125), Japanese Journal of Applied Physics, March 2004, pgs. 936-939, Vol. 43, No. 3, Japan Society of Applied Physics, Tokyo, Japan	<input type="checkbox"/>
	2	I. KATO ET AL., "New Method to Improve Electrical Characteristics of Low-k Dielectrics in Cu-Damascene Interconnections" (XP008060635), 2003 Advanced Metallization Conference, pgs. 699-704, Materials Research Society, Warrendale, PA	<input type="checkbox"/>
	3	J. A. LUBGUBAN ET AL., "Supercritical Carbon Dioxide Extraction to Produce Low-k plasma Enhanced Chemical Vapor Deposited Dielectric Films" (XP012032705), Applied Physics Letter, December 2, 2002, pgs. 4407-4409, Vol. 81, No. 23, American Institute of Physics, Melville, NY	<input type="checkbox"/>
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